



Inventor: Haining Yang

Title: **Methods of Forming Metal-Comprising Materials and Capacitor Electrodes; and Capacitor Constructions**

Assignee: **Micron Technology, Inc.**

Serial No.: **09/932,236**

Filed: **August 16, 2001**

COPY

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449, copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of the referenced art is respectfully requested.

This Supplemental Information Disclosure Statement is being filed after the filing of an RCE and before the mailing date of a first Office Action. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.

Respectfully submitted,

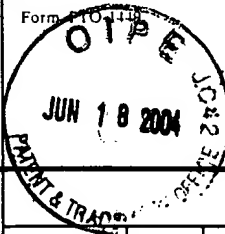
Date: 7/14/03

By: 

Robert C. Hyta
Reg. No. 46,791
Wells St. John P.S.

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Form PTO 1449 		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1725		SERIAL NO. 09.932.236		
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Haining Yang		GROUP 2813		
				FILING DATE August 16, 2001				
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	6,063,705	05/00	Vaartstra				
	AB	5,372,849	12/94	McCormick, et al.				
	AC							
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